

<b>Notice of References Cited</b>	Application/Control No. 10/024,606	Applicant(s)/Patent Under Reexamination. KAKU ET AL.	
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**U.S. PATENT DOCUMENTS**

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**FOREIGN PATENT DOCUMENTS**

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	N	JP 58073252 A	05-1983	Japan	MIURA et al.	H04B 09/00
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